Influence of annealing on structural and optical properties of Zn$_3$P$_2$ thin films

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Abstract

Zinc Phosphide films prepared by vacuum evaporation have been studied for their photovoltaic properties. X-ray diffraction studies reveal that the films are crystalline in nature and that the crystallinity improves with increase in film thickness and annealing temperature. Structural parameters such as crystallite size, strain and dislocation density are calculated for both annealed and un-annealed films and the results are discussed on the basis of film thickness and temperature. The films are highly absorbing in nature, and the transmittance and absorption seems to be thickness dependent. The band gap energy decreases with increase in film thickness as well as annealing temperature, and the possible transitions in these films are found to be direct and allowed.

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1. Introduction

Zinc Phosphide was studied as early as the 1950’s for its photovoltaic properties. Zinc Phosphide II–V is a polar semiconductor with mixed ionic-covalent bonds and has tetrahedral phases with sp$^3$ bonds [1]. Zn$_3$P$_2$ has a tetrahedral unit with atomic arrangement described by the D$_{4h}$$^{15}$ (P4$_2$/n mc) space group. Zn$_3$P$_2$ is a p-type material with a band gap of about 1.5 eV [2], it has an infrared carrier diffusion length of about 13 m [4–6], which is required to obtain a large optical absorption co-efficient ($>10^4$ cm$^{-1}$) [7]. This makes Zinc Phosphide near optimum for use in photovoltaic energy conversion. As a result, Zinc Phosphide has attracted much attention for photovoltaic applications [3]. This paper deals with the structural and optical properties of Zn$_3$P$_2$ films deposited under vacuum evaporation, with a comparative study between annealed and un-annealed Zn$_3$P$_2$ thin films.

2. Experimental details

Zinc Phosphide (99.999% pure, Aldrich chemicals, India) was deposited by vacuum evaporation onto well-cleaned glass substrates under a pressure of about 10$^{-5}$ m bar at 303 K. A constant rate of evaporation was maintained at 5 Å/s throughout the film preparation. All the films were grown at room temperature (303 K) and a copper–constantan thermocouple was employed to measure the temperature. A rotary drive was employed to maintain uniformity in film thickness during evaporation. The thickness of the films was
measured in-situ by a quartz crystal thickness monitor. The substrate-to-source distance was optimized to be 18 cm inside the vacuum chamber. The samples were annealed at 220 °C for 1 h in a hot air oven. The structural studies were carried out with a Shimadzu XRD-6000 X-ray diffractometer using CuKα radiation and the optical studies were carried out with a JASCO UV/VIS/NIR double beam spectrophotometer.

3. Results and discussion

Fig. 1a and b represents the XRD spectra of the as-deposited and annealed Zn₃P₂ films of thickness 3000 Å. The presence of humps for the as-deposited films leads us to understand that the Zn₃P₂ film has a mixed state of amorphous and microcrystalline structure. The amorphous nature arises due to the irregular arrangement of atoms and also due to the defects present in the crystal. The freshly prepared Zn₃P₂ films were subjected to annealing in the temperature range of 50 °C to 220 °C for 1 h in a hot air oven. It was observed that the annealed film does not show any significant change in the structure from the mixed state to a more crystalline nature until annealing above 200 °C. When Zn₃P₂ films are subjected to heat treatment the atoms take on a more regular arrangement, which leads to a polycrystalline nature of the film [8]. The XRD spectrum reveals that a sharp diffraction peak is observed for the diffraction angle 2θ=45° which corresponds to the (401) plane. However, a preferred orientation was also found for the diffraction angle at 2θ=27° and 30° for the (202) and (004) plane axes respectively. The observed results are in good agreement with the earlier reports [9,10]. These orientations i.e., (401), (202) and (004) are the close packed directions of the tetragonal structure and this type of ordering is often observed in polycrystalline α-Zn₃P₂ films [11–13]. The grain size (D) was calculated using the Scherrer formula [14] from the full width at half maximum (FWHM):

\[ D = \frac{k\lambda}{\beta \cos \theta} \]  

where, the constant \( k \) is the shape factor \( \approx 0.94 \), \( \lambda \) is the wavelength of the X-rays (1.5406 Å for CuKα), \( \theta \) is the Bragg’s angle and \( \beta \) is the FWHM. The

<table>
<thead>
<tr>
<th>Thickness (Å)</th>
<th>Experimental 2θ (°)</th>
<th>Experimental d (Å)</th>
<th>Theoretical d (Å)</th>
<th>h k l</th>
<th>FWHM (°)</th>
<th>Grain size D (nm)</th>
<th>Strain (ε)</th>
<th>Dislocation density (10⁴ lines/m²)</th>
</tr>
</thead>
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<tr>
<td>3000</td>
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<td>2.039</td>
<td>2.010</td>
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<td>10.46</td>
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<td>45.07</td>
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<td>2.010</td>
<td>4 0 1</td>
<td>0.0900</td>
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<td>1.175</td>
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<td>3.48</td>
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<td>2.010</td>
<td>4 0 1</td>
<td>0.0400</td>
<td>207.59</td>
<td>1.74</td>
<td>0.232</td>
</tr>
</tbody>
</table>
dislocation density ($\delta$) can be evaluated from the crystallite size ($D$) by the following relation:

$$\delta = \frac{1}{D^2}$$

The micro strain ($\varepsilon$) can be calculated from the following relation:

$$\varepsilon = \frac{\beta \cos \theta}{4}.$$  

The structural parameters were calculated and the results are given in Tables 1 and 2 for as-deposited and annealed Zn$_3$P$_2$ films of different thickness. For as-deposited films it is seen that the grain size ($D$) increases with an increase in film thickness. This may be due to columnar grain growth [15]. For annealed films it is observed that the grain size increases as thickness increases from 3000 to 5000 Å, whereas there is a decrease in grain size with thickness increasing from 5000 to 18,000 Å. This grain size increase may be due to the columnar growth, while the decrease in grain size may be due to the formation of secondary grains on the film surface [16]. The strain $\varepsilon$ of the films decreases with an increase in film thickness for as-deposited films, while the annealed films show an increase in strain, which may be due to thermal strain. The dislocation density $\delta$ decreases for annealed films when compared to as-deposited films, and this is due to atomic motion under heat treatment, which causes a decrease in dislocation density [17].

### Table 2
Structural parameters of annealed Zn$_3$P$_2$ films

<table>
<thead>
<tr>
<th>Thickness (Å)</th>
<th>$\theta$</th>
<th>$d$ (Å)</th>
<th>d (Å)</th>
<th>h k l</th>
<th>FWHM</th>
<th>Grain size $D$</th>
<th>Strain ($\varepsilon$)</th>
<th>Dislocation density ($10^{14}$ lines/m$^2$)</th>
</tr>
</thead>
<tbody>
<tr>
<td>3000</td>
<td>44.20</td>
<td>2.024</td>
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<td>0.5200</td>
<td>15.36</td>
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<tr>
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<td>2.050</td>
<td>2.010</td>
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<td>0.0400</td>
<td>207.58</td>
<td>1.74</td>
<td>0.232</td>
</tr>
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<td>45.97</td>
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<td>0.1400</td>
<td>59.31</td>
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<td>2.842</td>
</tr>
<tr>
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<td>2.001</td>
<td>2.010</td>
<td>4 0 1</td>
<td>0.1467</td>
<td>56.60</td>
<td>6.39</td>
<td>3.125</td>
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</table>

4. Optical properties

The transmission spectra for as-deposited and annealed films are shown in Fig. 2a and b. It is found that the percentage of transmittance decreases with increase in film thickness. For annealed samples the transmittance spectra exhibit good maxima and minima when compared to the as-deposited samples [18]. This
indicates improvement of internal film morphology and uniformity upon annealing. The absorption spectra measured as a function of photon wavelength for as-deposited films of thickness 260, 5000 and 10,000 Å is shown in Fig. 3. From the graph it can be positively concluded that the films are highly absorbing in nature, which is suitable for photovoltaic applications [19].

The energy dependence of the absorption coefficient \( \alpha \) near the band edge for band-to-band and exciton transitions in terms of the incident radiation energy are given below:

\[
\alpha = A(h\nu - E_g)^P
\]

where, ‘A’ is a constant, ‘\( E_g \)’ is the energy band gap, ‘\( \nu \)’ is the frequency of the incident radiation and ‘\( h \)’ is Plank’s constant. The magnitude of the exponent \( P \) is characteristic of the type of transition, and takes the value 1/2, 3/2, 2 and 3 for direct, allowed forbidden, indirect allowed and indirect forbidden transitions respectively. Zn\(_3\)P\(_2\) is a direct gap material and plotting \((\alpha h\nu)^2\) against the photon energy \((h\nu)\) (Fig. 4a and b) can give the band gap energy by extrapolating the linear portion to the energy axis.

The band gap energy was estimated from the plots and is given in the Table 3 for as-deposited and annealed Zinc Phosphide films. From Table 3 it is seen that the band gap energy decreases with the increase in film thickness. The estimated band gap values are in good agreement with the earlier reports [20]. This decrease in optical band gap energy may be due to many reasons, including the presence of an internal electric field associated with the defects in the film, or the increased grain growth of the film at higher thickness.

5. Conclusions

The structure of Zn\(_3\)P\(_2\) films was found to be amorphous and polycrystalline for films of lower and higher thickness respectively. The grain size increases with the increase in film thickness for as-grown films whereas the strain and dislocation density decreases. The grain size decreases due to annealing as a result of a quantum size effect. The material is of a highly absorbing nature. The band gap energy decreases with the increase in film thickness and annealing temperature. The optical transition is found to be direct and allowed.

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References


<table>
<thead>
<tr>
<th>Thickness (Å)</th>
<th>Band gap energy of as-grown Zn(_3)P(_2) films (eV)</th>
<th>Band gap energy of annealed Zn(_3)P(_2) films (eV)</th>
</tr>
</thead>
<tbody>
<tr>
<td>260</td>
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<tr>
<td>5000</td>
<td>1.90</td>
<td>1.78</td>
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<tr>
<td>10,000</td>
<td>1.70</td>
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<tr>
<td>18,000</td>
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